

The logo for EPFL (École Polytechnique Fédérale de Lausanne) is displayed in a bold, red, sans-serif font. It consists of the letters 'EPFL' in a stylized, blocky typeface.

Génie Electrique et Electronique
Master Program
Prof. Elisa Matioli

A large red rectangular box containing white text. The text is centered and reads: 'EE-557', 'Semiconductor devices I', and 'Metal-Semiconductor Junction' stacked vertically.

EE-557
Semiconductor devices I
Metal-Semiconductor Junction

Outline of the lecture

Metal-Semiconductor Junction

- Schottky contacts
- Ohmic contacts

References:

- J. A. del Alamo, course materials for 6.720J Integrated Microelectronic Devices, Spring 2007. MIT OpenCourseWare (<http://ocw.mit.edu/>)

- How exactly does **current flow** happen in a metal-semiconductor junction ?
- What are the **key dependences of the current** in a metal-semiconductor junction?

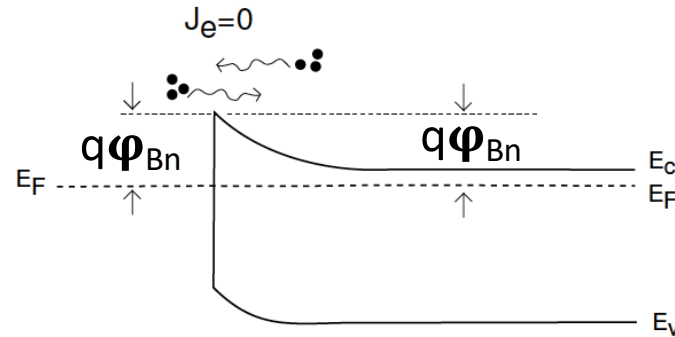
Metal-semiconductor junction outside TE

I-V Characteristics

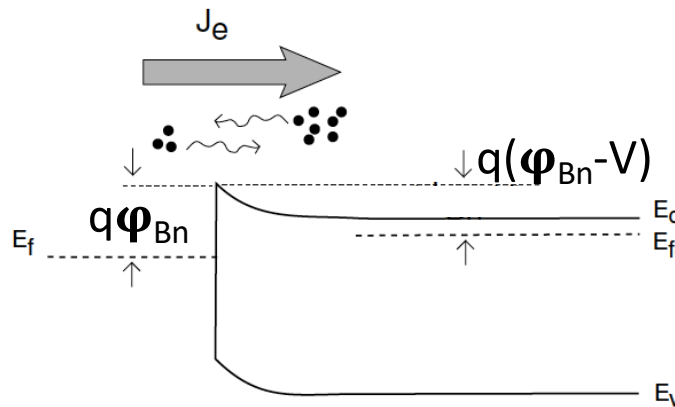
Few minority carriers anywhere
→ **majority carrier device**

Bottleneck: transport through SCR

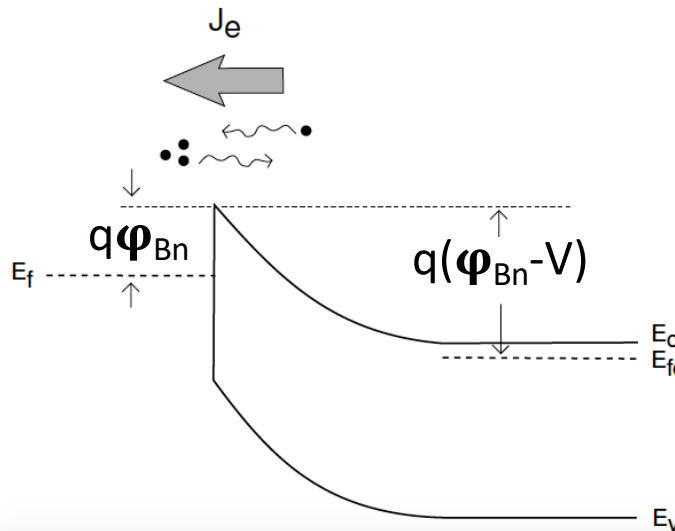
- In forward bias, $J \propto e^{qV/kT}$
- In reverse bias, J saturates with V



a) equilibrium



b) forward bias



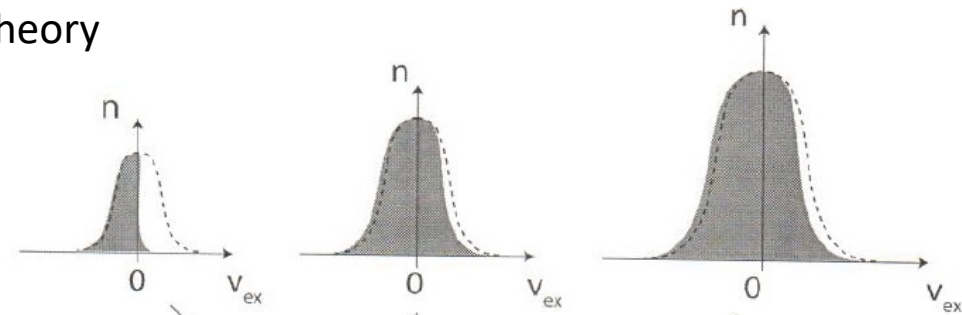
c) reverse bias

Thermionic-emission theory

Closer than a mean free path from the interface, arguments of drift and diffusion do not work!

In the last mean free path,

- electrons do not suffer any collisions,
- only those with enough E_K get over the barrier.
- actually, only half of those with enough E_K do!
- This is bottleneck: thermionic emission theory

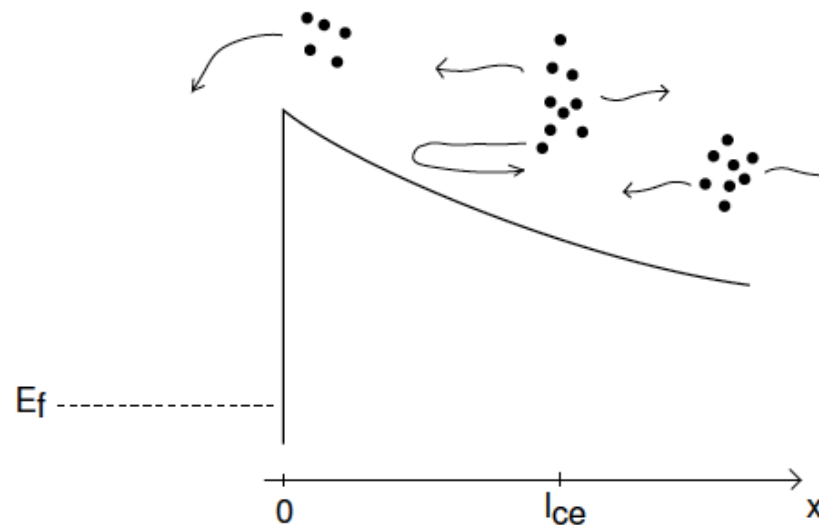


In steady state:

Focus on bottleneck at $x=0$:

$$J_t \simeq J_e = -qn(x)v_e(x)$$

$$J = -qn(0)v_e(0)$$



First compute $n(0)$:

$n(0)$ is only a fraction of the carriers present at $n(l_{ce})$:

$$n(0) = \frac{n(l_{ce})}{2} \exp \frac{q[\phi(0) - \phi(l_{ce})]}{kT}$$

If rest of SCR is in quasi-equilibrium

$$n(l_{ce}) \simeq N_D \exp \frac{q\phi(l_{ce})}{kT}$$

$$\phi(0) = -(\phi_{bi} - V)$$

$$n(0) = \frac{N_D}{2} \exp \frac{-q(\phi_{bi} - V)}{kT} = \frac{N_c}{2} \exp \frac{-q(\varphi_{Bn} - V)}{kT}$$

$n(0)$ is exactly half of what one would obtain if it was a bulk semiconductor in TE

All electrons at $x = 0$ are injected into metal

only half the electrons move toward the interface!

Note $\propto e^{qV/kT}$ dependence of $n(0)$

Metal-semiconductor junction outside TE

Then compute $v_e(0)$:

Over the last mean free path, carriers basically travel at v_{th}

But, velocity pointing at different angles. After taking care of statistics:

$$\bar{v}_{x+} = \frac{\int_0^{\infty} v_x e^{-mv_x^2/2kT} dv_x}{\int_0^{\infty} e^{-mv_x^2/2kT} dv_x} \longrightarrow v_e(0) = -\frac{v_{th}}{2} = -\sqrt{\frac{2kT}{\pi m_{ce}^*}}$$

(minus sign indicates that electrons are traveling against x)

Finally, electron current:

$$J = A^* T^2 \exp\left(\frac{-q\phi_{Bn}}{kT}\right) \exp\left(\frac{qV}{kT}\right)$$

with

$$A^* = \frac{4\pi q k^2 m_o}{h^3} \sqrt{\frac{\left(\frac{m_{de}^*}{m_o}\right)^3}{\frac{m_{ce}^*}{m_o}}}$$

$A^* \equiv$ Richardson's constant

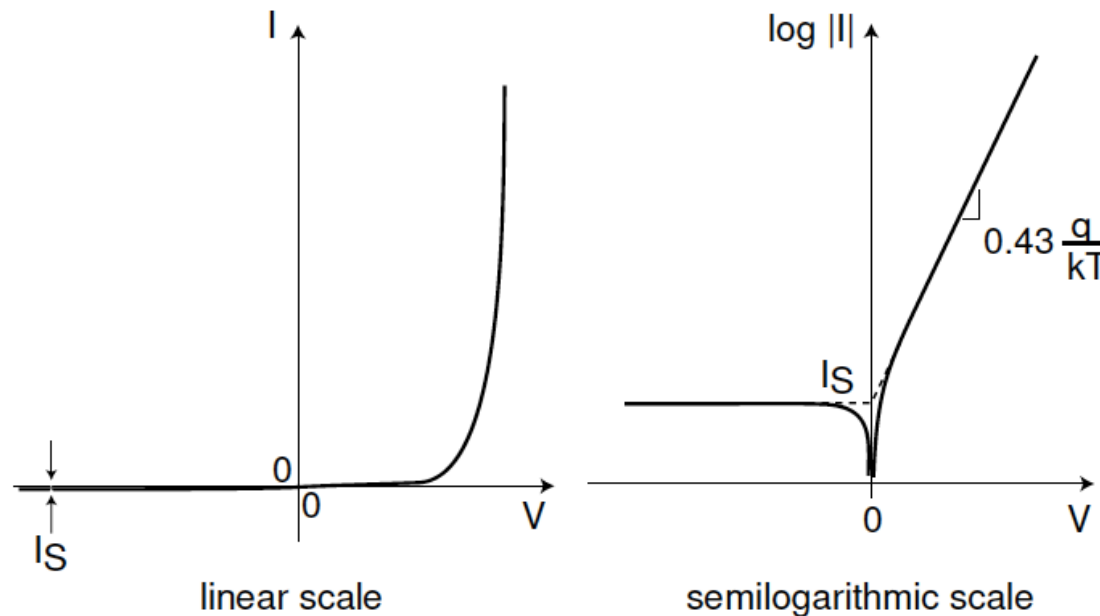
Metal-semiconductor junction outside TE

Still must **subtract electron injection from metal to semiconductor in TE**,
so that when $V \rightarrow 0$, $J \rightarrow 0$:

$$J = A^*T^2 \exp\left(-\frac{q\phi_{Bn}}{kT}\right) \left(\exp\left(\frac{qV}{kT}\right) - 1\right)$$

Valid in forward and reverse bias.

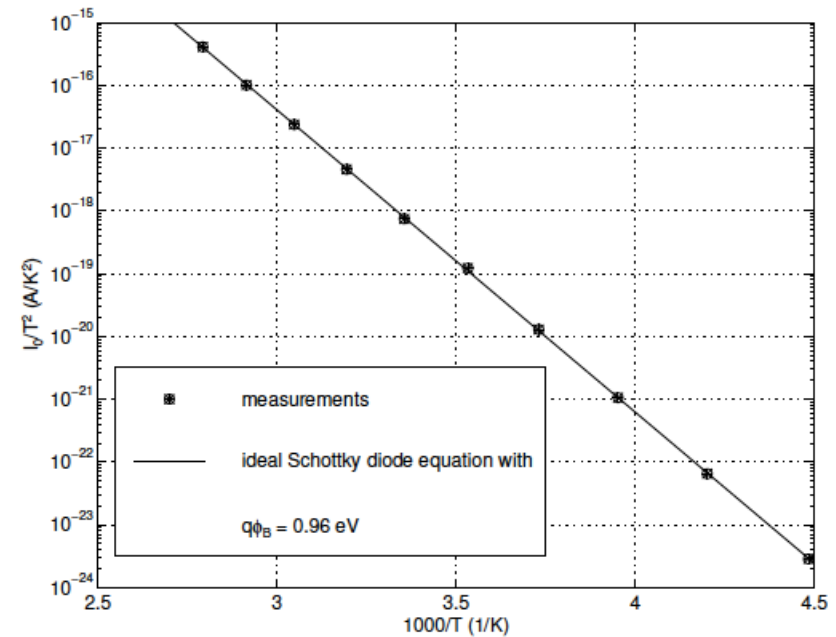
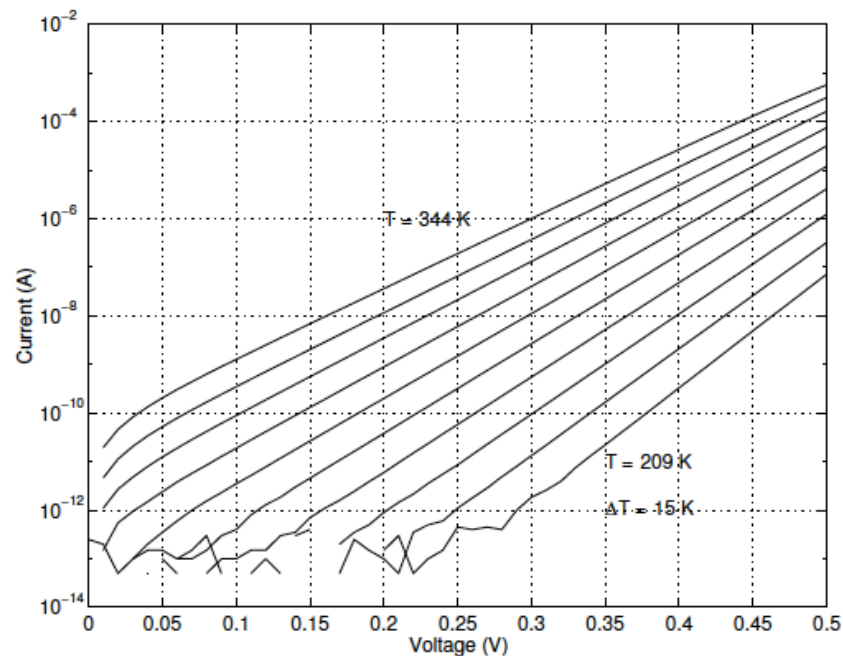
$$I_S = A_j A^* T^2 \exp\left(-\frac{q\phi_{Bn}}{kT}\right) \quad I_S: \text{Saturation current}$$



$$J = A^*T^2 \exp\left(-\frac{q\phi_{Bn}}{kT}\right) \left(\exp\left(\frac{qV}{kT}\right) - 1\right)$$

$$I_S = A_j A^* T^2 \exp\left(-\frac{q\phi_{Bn}}{kT}\right)$$

I_S/T^2 is thermally activated with activation energy $E_a = q\phi_{Bn}$



Thermionic emission theory valid if: thermionic current \ll drift current for $l_{ce} \leq x \leq x_d$.

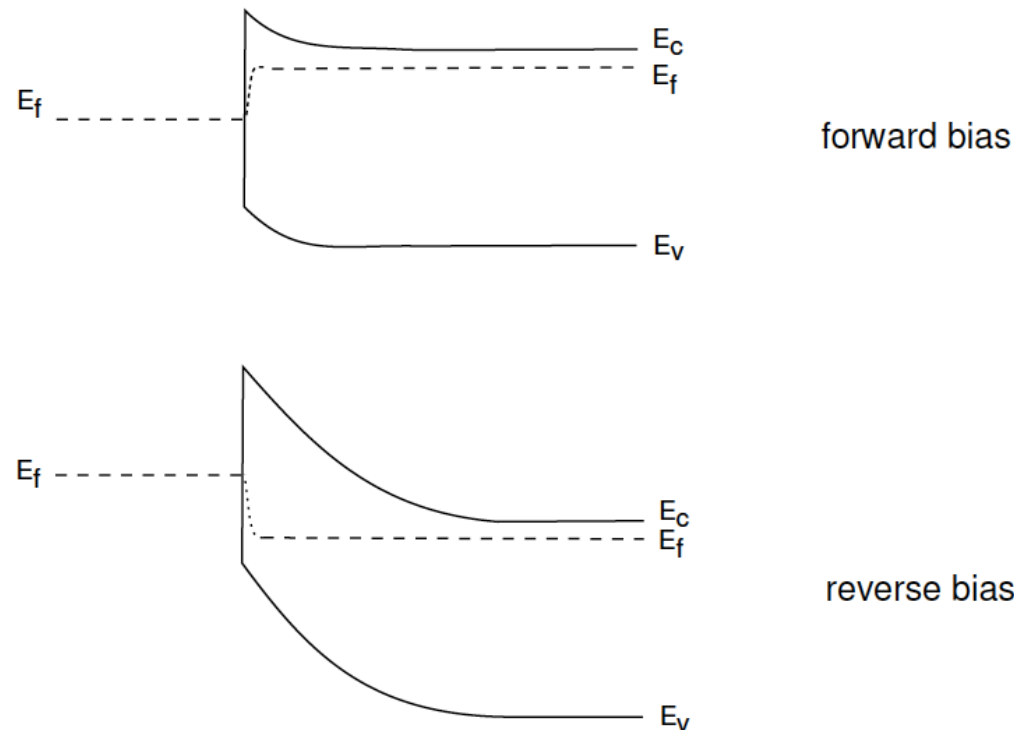
Bethe condition: $l_{ce} |\mathcal{E}_{max}| > 1.5 \frac{kT}{q}$ (Potential drop in the first mean free path $>$ 1.5x thermal potential)

Easily satisfied in Si at around room temperature (mean free paths are rather long).

If thermionic emission theory applies:

E_{fe} flat throughout SCR up to $x = l_{ce}$.

Beyond $x = l_{ce}$, E_{fe} has no physical meaning (electron distribution is not Maxwellian!)



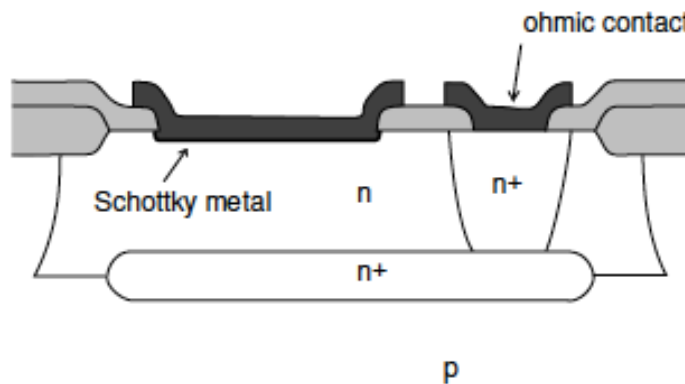
Schottky diode

Key uniqueness: fast switching from ON to OFF and back, since it is a majority carrier device

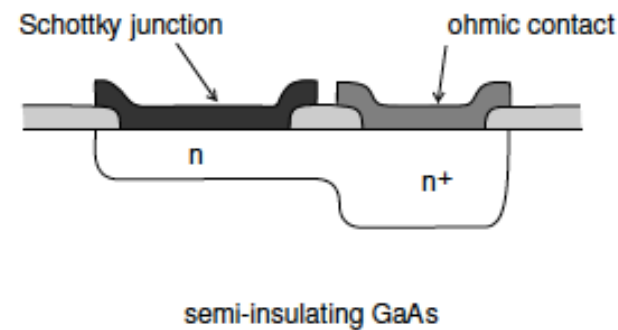
Widely used:

- in analog circuits: in track and hold circuits in A/D converters, pin drivers of IC test equipment
- In communications and radar applications: as detectors and mixers, also as varactors

Typical implementations:



Silicon



GaAs

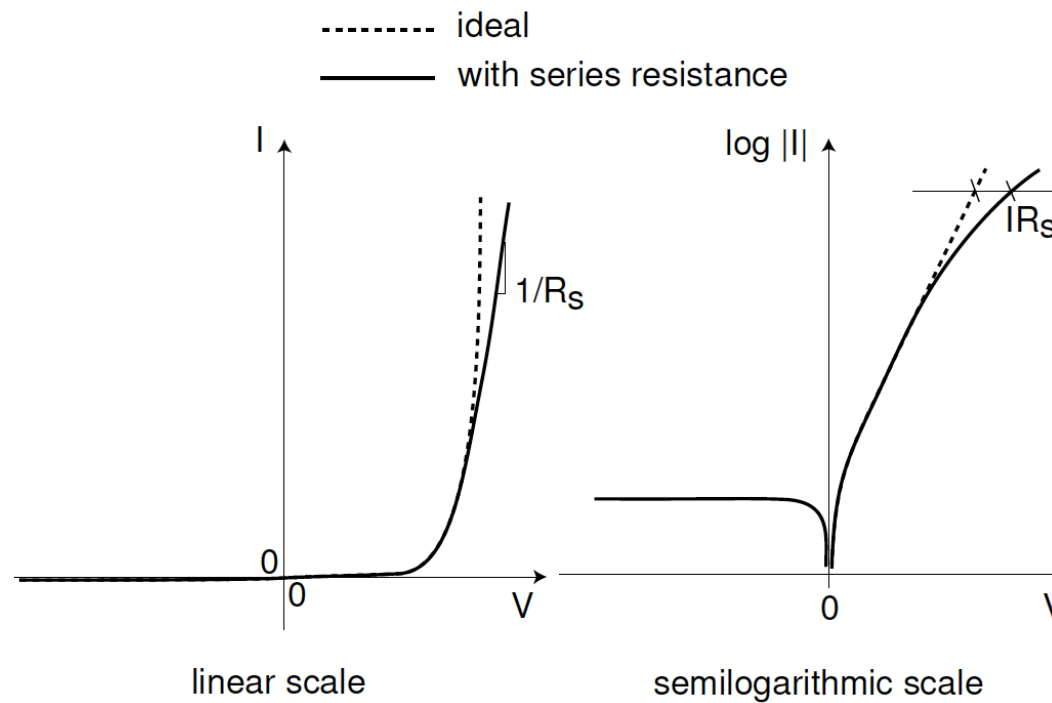
Schottky diode

Parasitics

Series resistance due to QNR ohmic drop

Voltage across junction is reduced and I-V characteristics modified:

$$I = I_S \left[\exp \frac{q(V - IR_s)}{kT} - 1 \right]$$



R_s bad because:

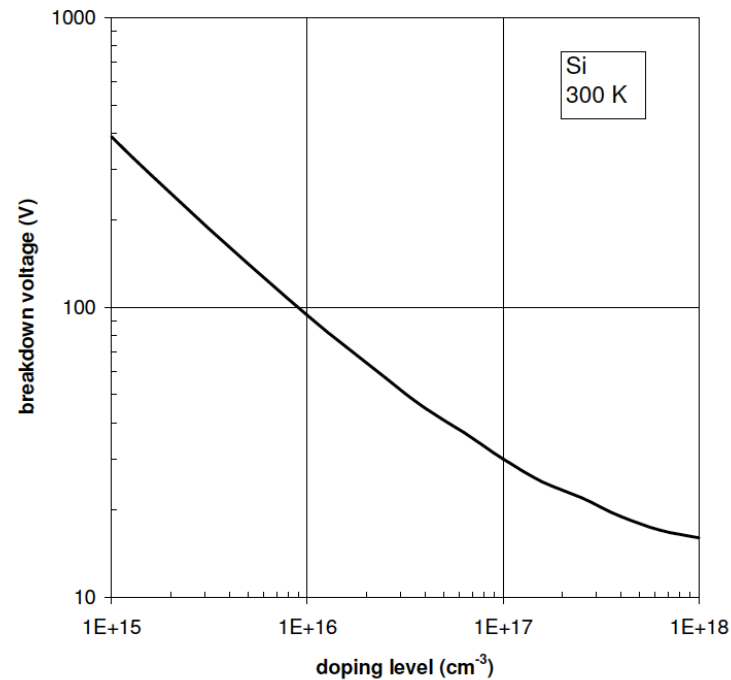
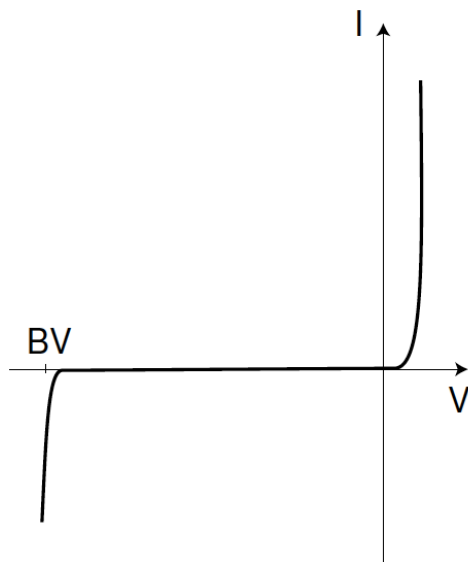
For given forward current, V increased and harder to control

it degrades dynamic response of diode

Breakdown

In reverse bias, as $|V| \uparrow \rightarrow |E_{\max}| \uparrow$

At a high-enough voltage, avalanche breakdown takes place \rightarrow breakdown voltage



For moderate doping levels, BV function of N_D alone (independent of ϕ_{Bn}):

For similar doping levels, BV is typically smaller than in Schottky diodes: high electric field occurs at the sharp interface of the metal and semiconductor (in pn junctions high fields are inside semiconductors)

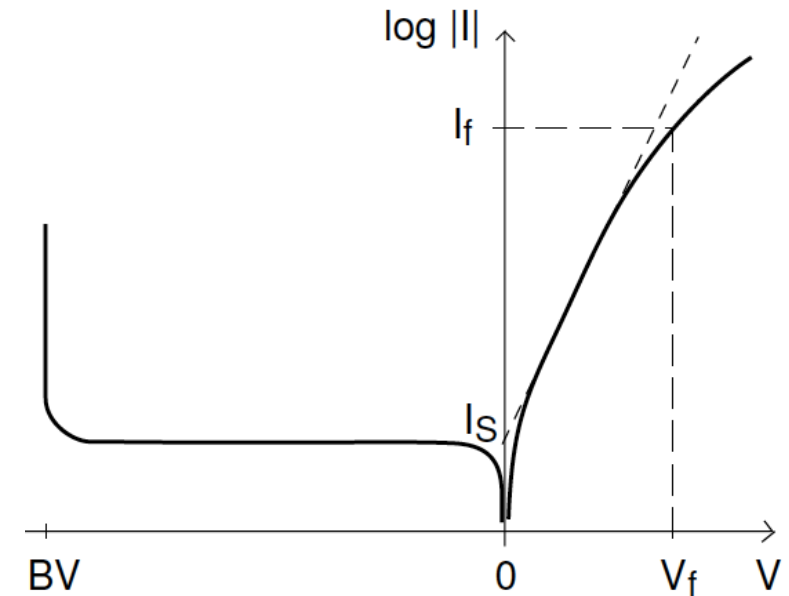
Schottky diode

Design issues:

Metal selection: $\varphi_{Bn} \uparrow \rightarrow V_f$ (for fixed I_f) \uparrow
 $\rightarrow I_S \downarrow$
 \rightarrow more T sensitivity

Doping level selection:

$N_D \uparrow \rightarrow R_s \downarrow$
 $\rightarrow C \uparrow$
 $\rightarrow BV \downarrow$

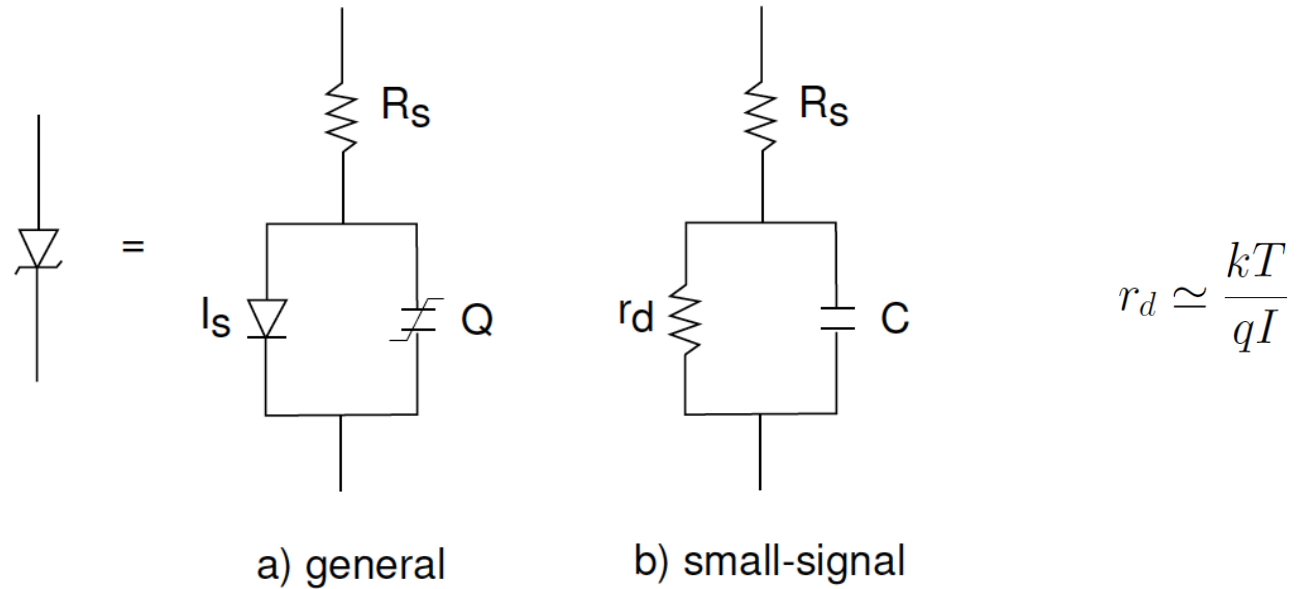


Vertical extension of QNR: minimum value of t required to deliver BV (beyond that, $R_s \uparrow$)

Diode area:

$A_j \uparrow \rightarrow C \uparrow$
 $\rightarrow I_S \uparrow$
 $\rightarrow R_s \downarrow$
 $\rightarrow V_f$ (for fixed I_f) \downarrow
 \rightarrow more expensive

Equivalent circuit models

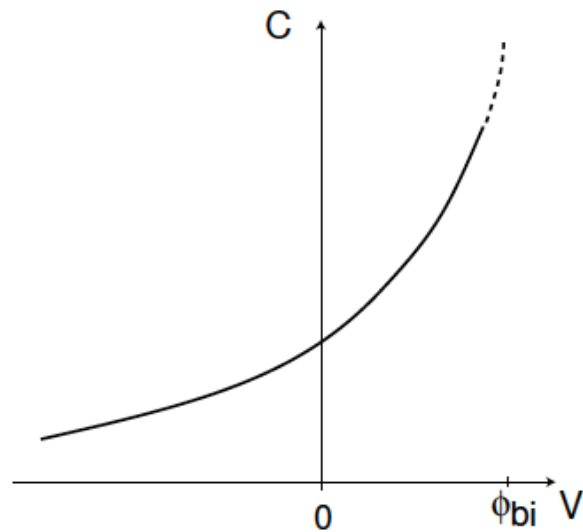


General model:

“Ideal diode” in parallel with capacitor and in series with resistor. Ideal diode is element with exponential I-V characteristics and no capacitances

$$I = I_S \left(\exp \frac{qV}{kT} - 1 \right)$$

Capacitance in Schottky diodes is much smaller than in pn junctions:



$$C(V) = \frac{\epsilon}{x_d(V)}$$

$$C(V) = \sqrt{\frac{\epsilon q N_D}{2(\phi_{bi} - V)}} = \frac{C(V = 0)}{\sqrt{1 - \frac{V}{\phi_{bi}}}}$$

Equivalent circuit models (real example)

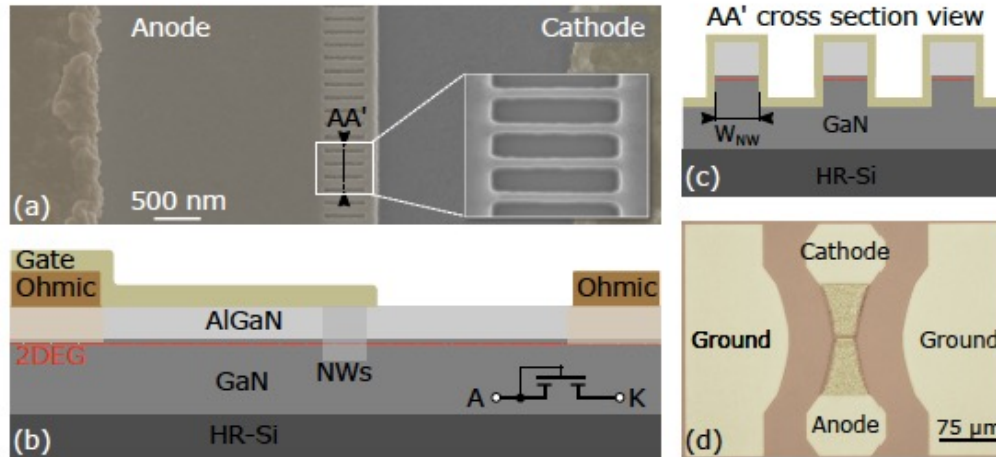


Fig. 1. (a) SEM image of a 30 nm-wide NW-FER. The inset shows the NW array before gate metal deposition. (b) Lateral and (c) cross-section (along AA') schematics of the device. (d) Optical image of a NW-FER showing the ground-signal-ground (GSG) pads for RF measurements.

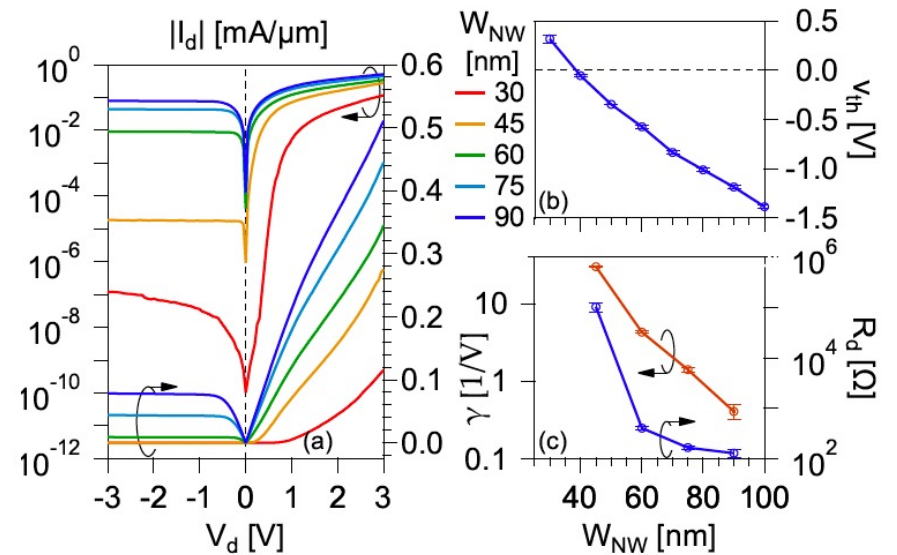
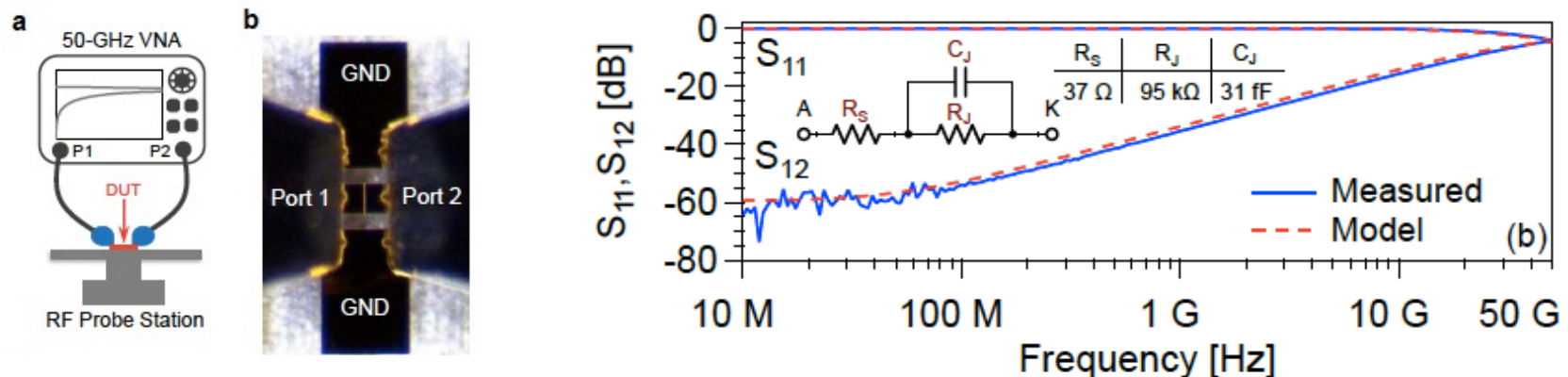
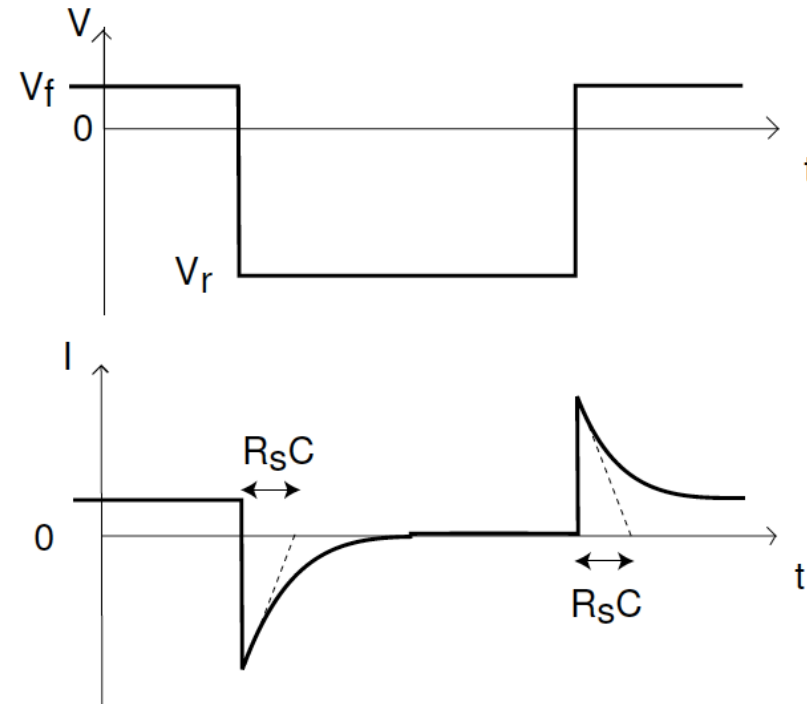
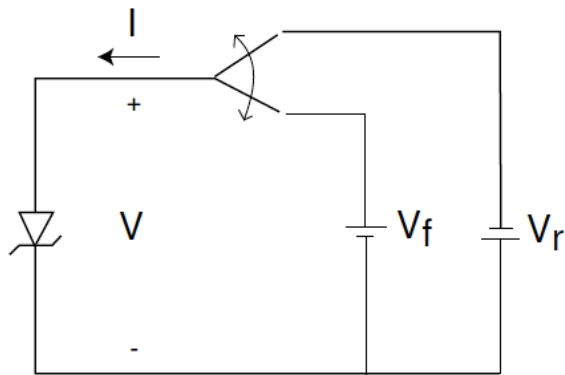


Fig. 2. (a) Diode current $|I_d|$ versus voltage V_d in logarithmic (left axis) and linear (right axis) scales for NW FERs with NW widths of 30 nm, 45 nm, 60 nm, 75 nm and 90 nm. (b) V_{th} (defined at $1 \mu A/mm$) for Schottky tri-gate HEMTs versus NW width. (c) γ and R_d at $V_d = 0$ V for NW-FER with NW width from 45 nm to 90 nm (devices with 30 nm wide NWs are not shown since they cannot work as zero bias diode due to the large V_{on}).



Uniqueness of Schottky diodes: they switch fast!

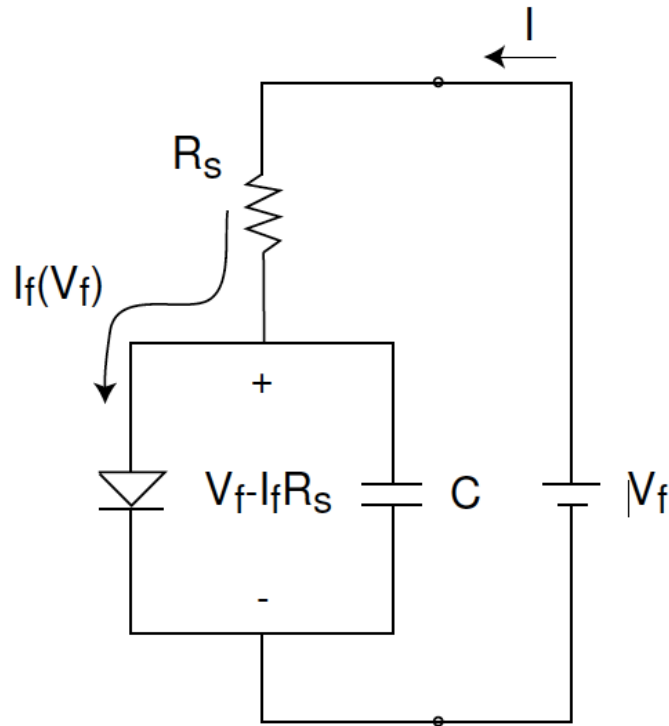
Large-signal example:



switch-off transient: C charges up through R_s time constant: $\sim R_s C$

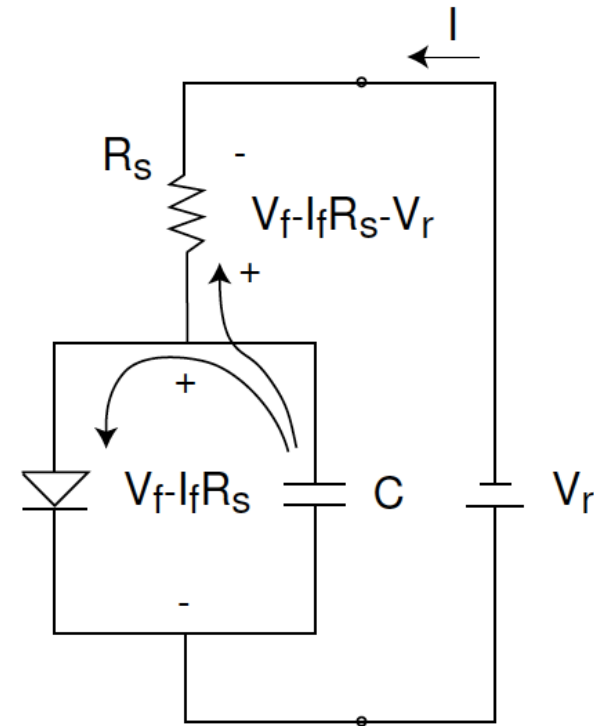
switch-on transient: C discharges through R_s time constant: $\sim R_s C$

Switch-off transient:



$t=0^-$

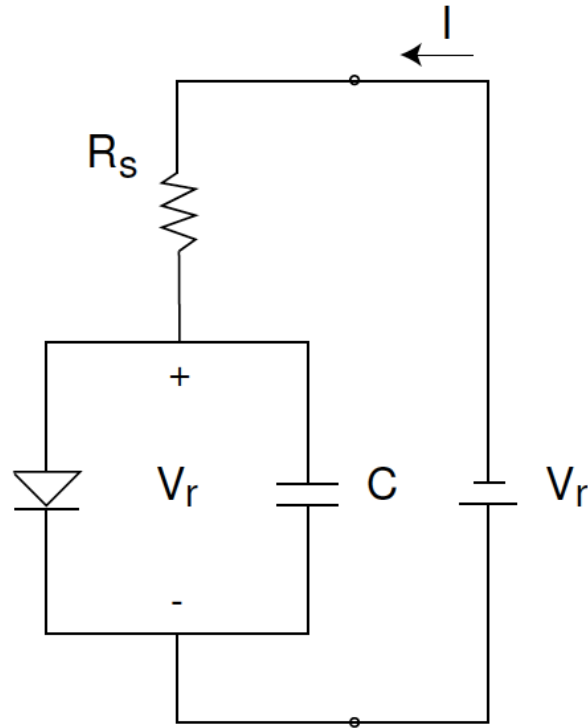
$$I(0^-) = I_f(V_f)$$



$t=0^+$

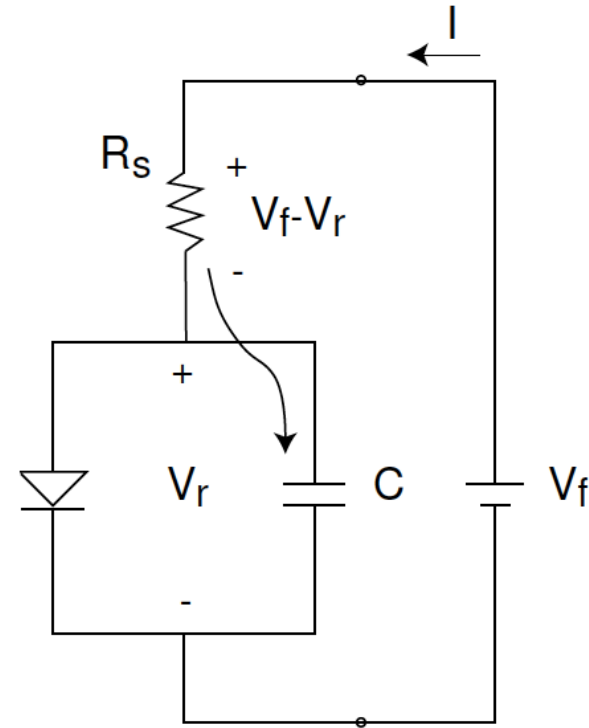
$$I(0^+) = -\left(\frac{V_f - V_r}{R_s} - I_f\right)$$

Switch-on transient:



$t=0^-$

$$I(0^-) = -I_s$$



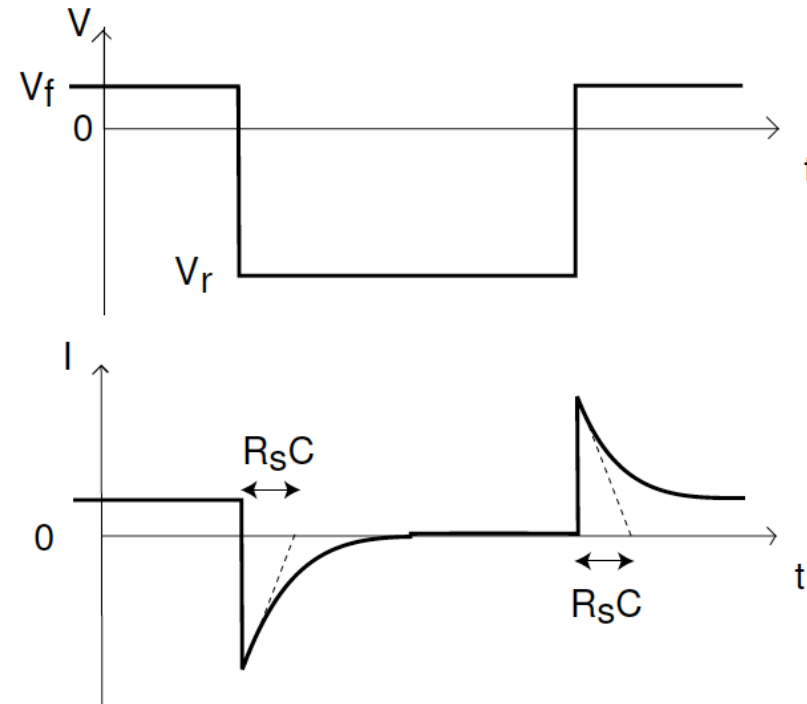
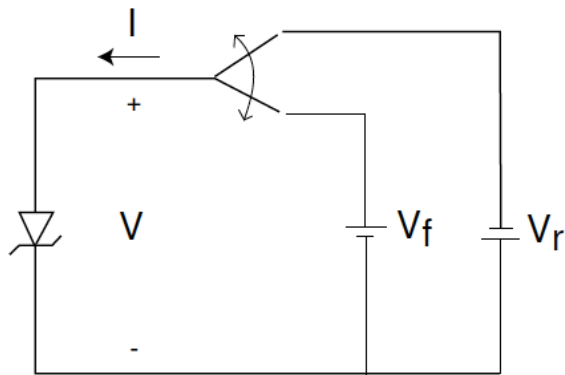
$t=0^+$

$$I(0^+) = \frac{V_f - V_r}{R_s}$$

note: in this notation, V_r is negative

Uniqueness of Schottky diodes: they switch fast!

Large-signal example:



switch-off transient: C charges up through R_s time constant: $\sim R_s C$

switch-on transient: C discharges through R_s time constant: $\sim R_s C$

For fast switching \Rightarrow minimize R_s and C

Ohmic contacts: means of electrical communication with outside world.

- Key requirement: very small resistance to carrier flow back and forth between metal and semiconductor.
- Can support substantial currents in both forward and reverse biases.
- Achieved by highly doping the semiconductor at the metal interface
- Ohmic contact = MS junction with large J_s
- V small \rightarrow linearize I-V characteristics:

$$J \simeq A^* T^2 \exp \frac{-q\varphi_{Bn} + qV}{kT} = \frac{V}{\rho_c}$$

Figure of merit for ohmic contacts:

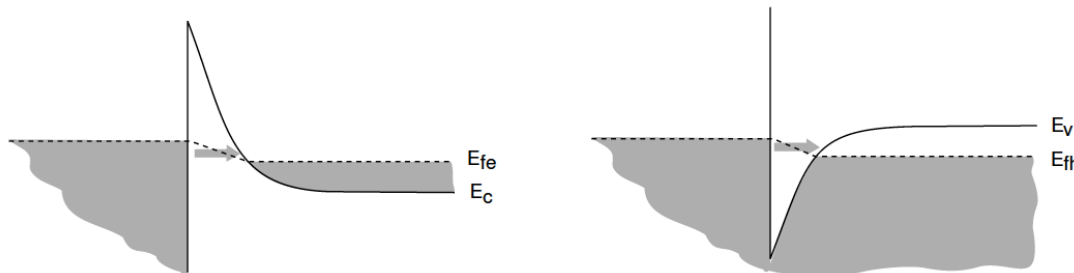
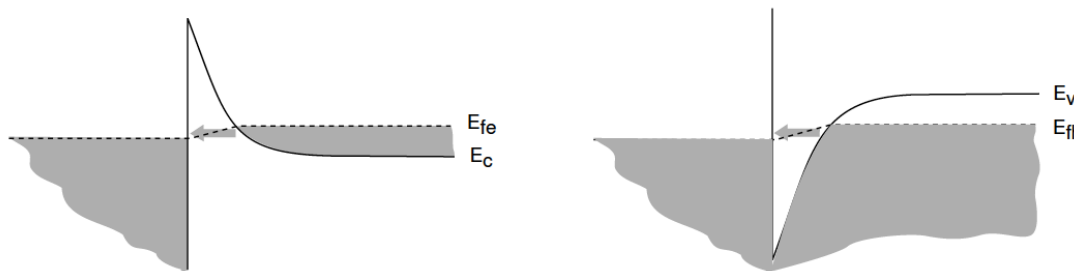
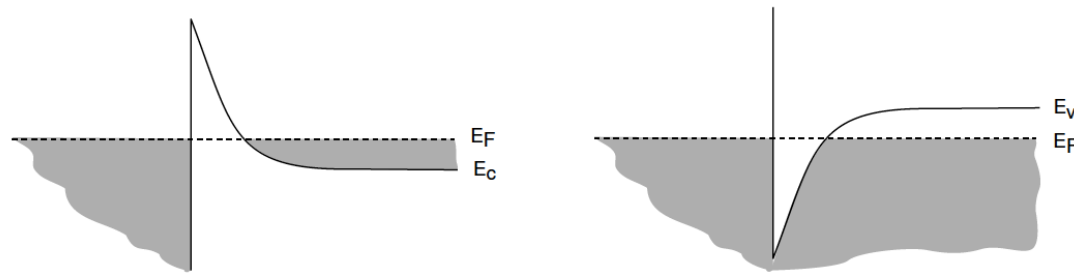
$\rho_c \equiv$ ohmic contact resistivity ($\Omega \cdot \text{cm}^2$)

Good values: $\rho_c \leq 10^{-7} \Omega \cdot \text{cm}^2$

Ohmic contact

How does one make a good ohmic contact?

- Classically, use metal that yields **small $q\phi_{Bn}$**
- **Increase N_D** until carrier tunneling is possible



ohmic contact to n-type semiconductor

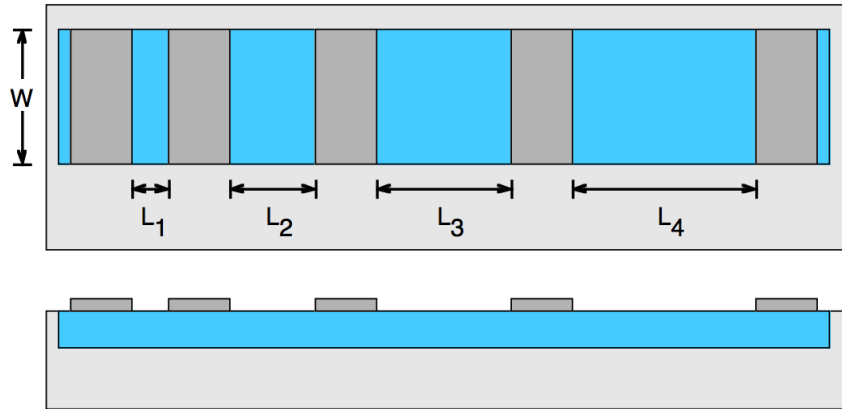
ohmic contact to p-type semiconductor

Ohmic contact resistance:

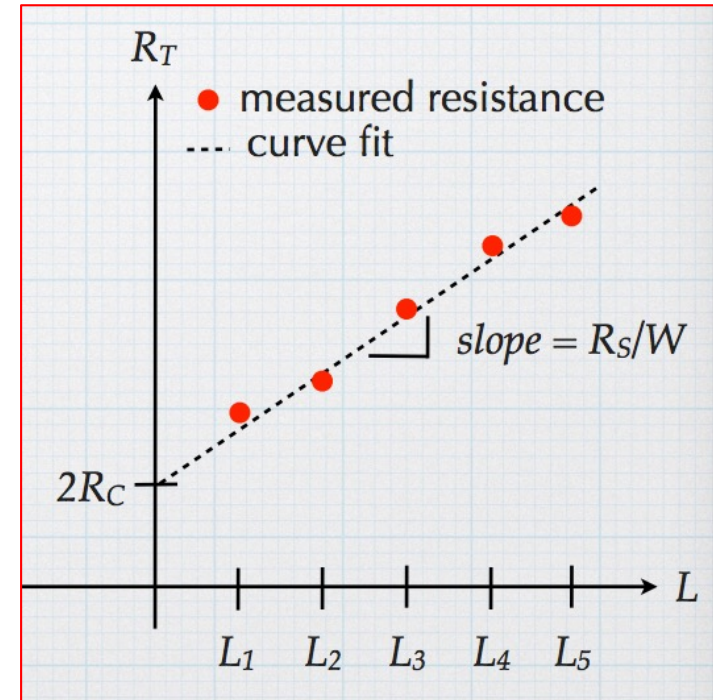
$$R_c = \frac{\rho_c}{A_c}$$

$$A_c \uparrow \Rightarrow R_c \downarrow$$

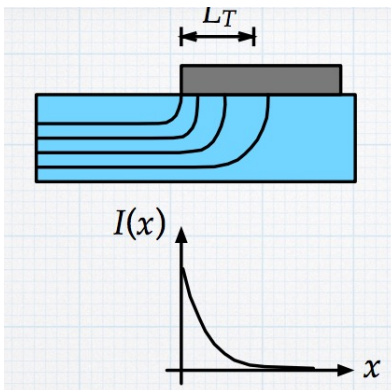
Transmission line measurement (TLM)



$$R_T = \frac{R_S}{W} (L + 2L_T)$$



At the edge of the contact, the current flowing in (or out) is significant. Moving away from that edge, the current drops off until, at the far edge, there is no current: current crowding



L_T is the transfer length

$$L_T = \sqrt{\frac{\rho_C}{R_S}}$$

The effective area of the contact can be treated as $L_T W$:

$$R_C = \frac{\rho_C}{L_T W} = \frac{R_S L_T}{W}$$

Key conclusions

Minority carriers play **no role in I-V characteristics of MS junction**.

Energy barrier preventing carrier flow from S to M modulated by V, barrier to carrier flow from M to S unchanged by V \Rightarrow rectifying behavior:

$$I = I_S \left(\exp \frac{qV}{kT} - 1 \right)$$

Drift-diffusion theory of current exhibits several dependences observed in devices, but fails temperature dependence.

Thermionic emission theory of current: bottleneck is flow of carriers over energy barrier at M-S interface. Transport at this bottleneck is of a ballistic nature.

I_S/T^2 is thermally activated; activation energy is $q\phi_{Bn}$.

Ideal BV of Schottky diode entirely set by doping level.

No minority carrier storage in Schottky diode \Rightarrow fast switching.

Dominant time constant of Schottky diode: $R_s C$.

Good ohmic contacts fabricated by increasing doping level \Rightarrow carrier tunneling.

ρ_c , specific contact resistance (in $\Omega \cdot \text{cm}^2$), in Si at 300K: $\rho_c < 10^{-7} \Omega \cdot \text{cm}^2$